

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF: Jaehwan EUN, et al
SERIAL NO: 10/539,886
FILED: June 17, 2005 CONFIRMATION NO: 1951
TITLE: METHOD FOR PREPARING FILM STRUCTURE
COMPRISING FERROELECTRIC SINGLE CRYSTAL
LAYER
GROUP: 1791 EXAMINER: Sonya MAZUMDAR

NOTICE OF APPEAL

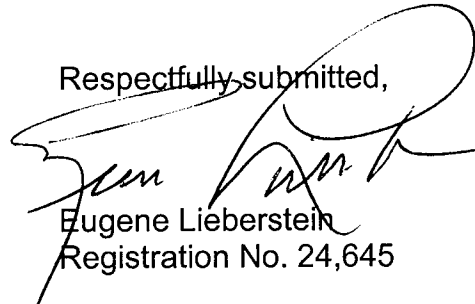
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

SIR:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner dated June 30, 2008 finally rejecting all the pending claims in the present application. A timely response to the final rejection was filed on June 17, 2008.

The required filing fee under 37 C.F.R. §1.17(e) for a Notice of Appeal, as well as any additional fees which may be required, should be charged to Applicant's Deposit Account No. 504581.

Respectfully submitted,



Eugene Lieberstein
Registration No. 24,645

Dated: September 16, 2008

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being sent to the U.S. Patent and Trademark Office via EFS Web to the Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on September 16, 2008.

By 
Audrey de Souza